# DTTO REPCT/PTO 1 4 MAR 2003

DOCKET NO.: 4856/PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE PCT NATIONAL PHASE PATENT APPLICATION

OF: Matthias AIKELE et al.

USPS EXPRESS MAIL

USSN: TO BE ASSIGNED - NEW

EV 511 024 620 US

FILED: March 14,2005

MARCH 14 2005

FOR: Method For Producing Insulation

Structures

INTERNATIONAL SERIAL NO.: PCT/DE2003/003049

INTERNATIONAL FILING DATE: 12 September 2003 (12.09.2003)

MS PCT COMMISSIONER FOR PATENTS P. O. BOX 1450 ALEXANDRIA, VA 22313-1450

March 14, 2005

## INFORMATION DISCLOSURE STATEMENT

Dear Sir:

- Pursuant to 37 C.F.R. 1.56, 1.97 and 1.98 applicants enclose a Form PTO-1449 and make of record the documents listed thereon. A copy of the English version of the International Search Report issued in the counterpart PCT International Application on November 11, 2004 is enclosed. Copies of references AA, AB, AE and AF are not (and need not be) enclosed, because they were transmitted to the USPTO by the International Searching Authority in the International processing of this PCT Application.
- 2) This statement is being filed concurrently with the above identified new PCT National Phase Application.

The PTO did not receive the following listed Item(s)\_\_\_\_\_

- 3) References AA to AF are in English. References AC and AD have been discussed at pages 1 and 2 of the specification. Therefore, no further discussion of the references is required.
- 4) Moreover, the enclosed Search Report indicates the degree of relevance of each of the references AA, AB, AE and AF by category (A = technological background). Thereby, a concise explanation of the relevance has been provided (see M.P.E.P. §609).
- 5) The Examiner is requested to consider all references of record, return an initialed copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

Respectfully submitted,

Matthias AIKELE et al. Applicant

WFF:hc/4856/PCT Encls.: postcard, First Form PTO-1449, copy of English Version of International Search Report

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USPS EXPRESS MAIL EV 511 024 620 US MARCH 14 2005

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# Sheet 1 1 FIRST IDS LIST OF REFERENCES CITED BY APPLICANT (FORM PTO-1449) DATED: March 14, 2005

Atty. Docket No. 1000 PC VSerial No.:
4856/PCT To Be Assigned

Applicant: Matthias AIKELE et al.

U.S. Filing Date: March 14, 2005 Art Unit:

### U. S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	Cl.	Sub- Cl.	Fil. Date
	AA	5,041,898	08/1991	Urabe et al.	-	_	-
	AB	5,747,377	05/1998	Wu	-	-	-
	AC	5,930,595	07/1999	Sridhar et al.	-	-	
	AD	6,239,473	05/2001	Adams et al.	-	_	1-
	AE	6,342,427	01/2002	Choi et al.	_	_	-

#### FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	cı.	Sub- Cl.	Trans.	
						Yes	No

#### OTHER DOCUMENTS

*	AF	Chunbo Zhang et al.; "Fabrication of thick silicon dioxide layers using DRIE, oxidation and trench refill"; IEEE, 2002, pages 160-163, XP010577620

EXAMINER'S SIGNATURE

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.